

FIGURE 1A (PRIOR ART)

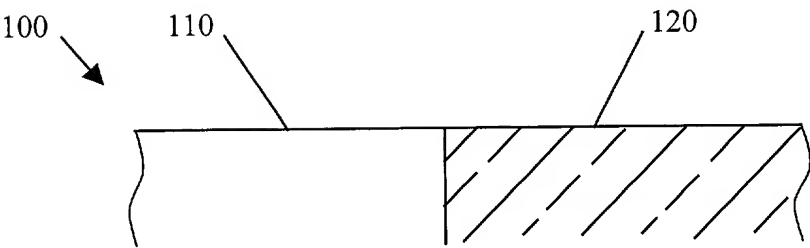


FIGURE 1B (PRIOR ART)

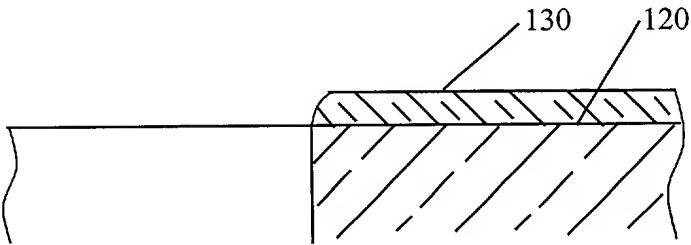


FIGURE 1C (PRIOR ART)

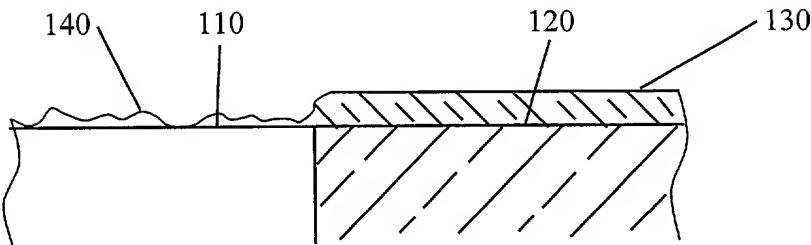


FIGURE 2A

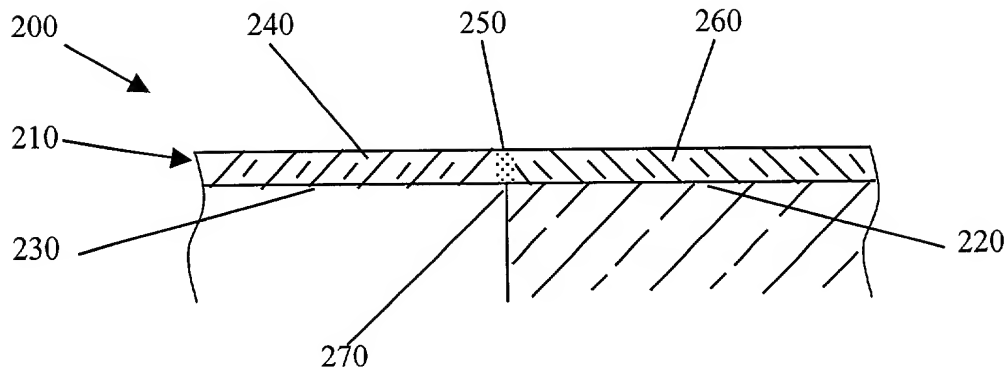


FIGURE 2B

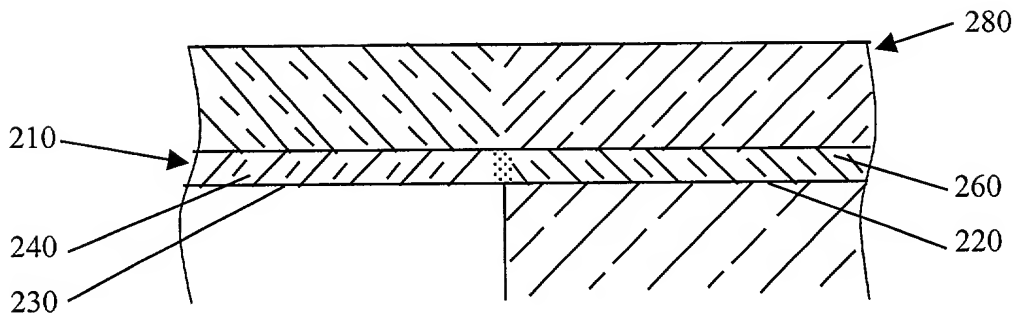


FIGURE 3A

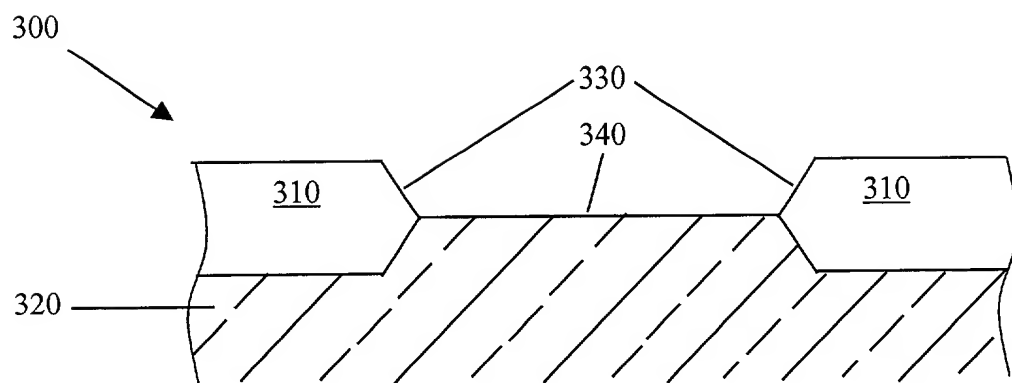


FIGURE 3B

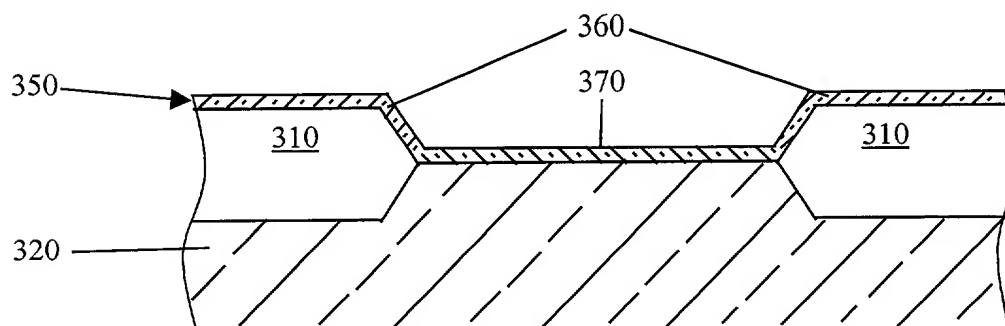
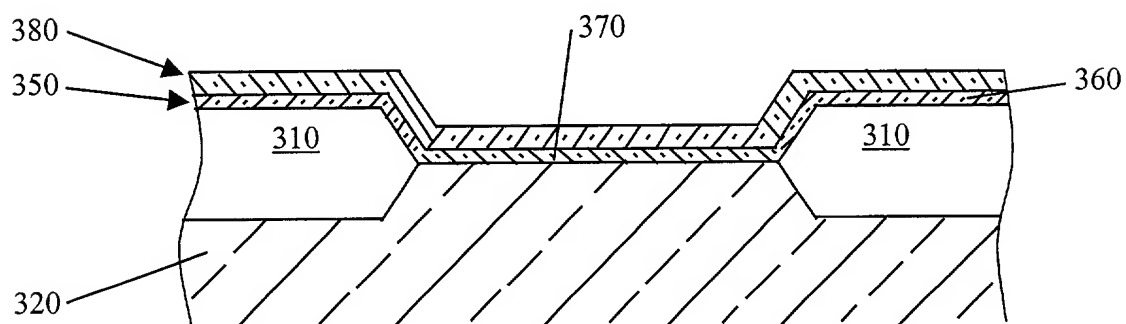
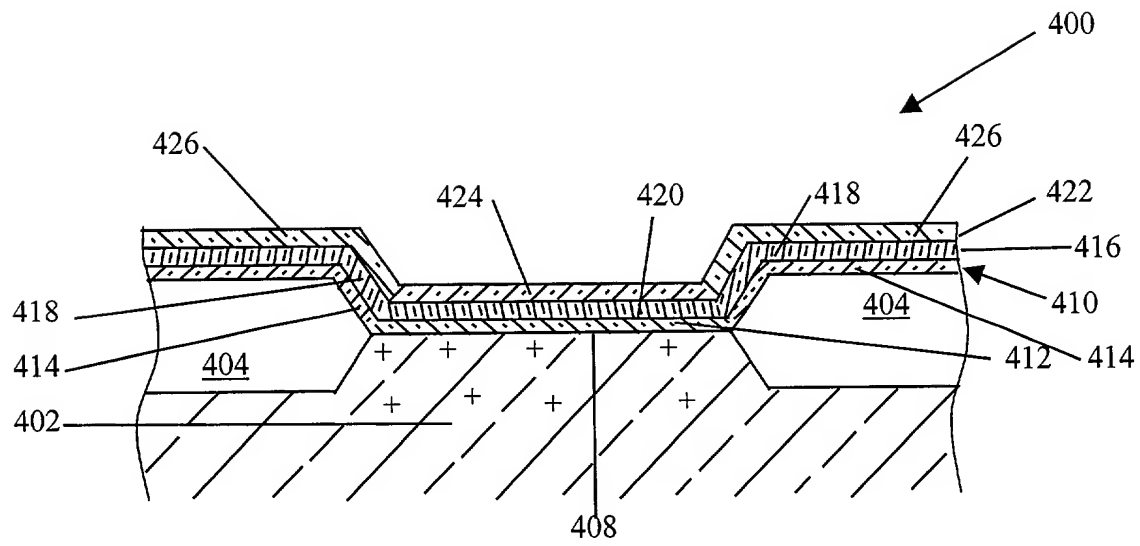
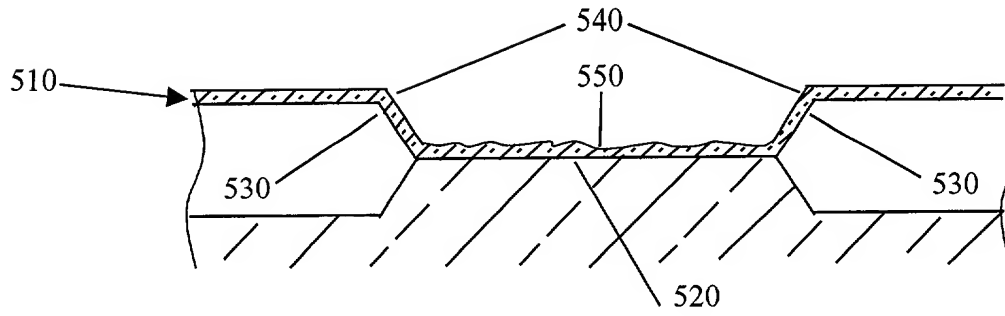


FIGURE 3C

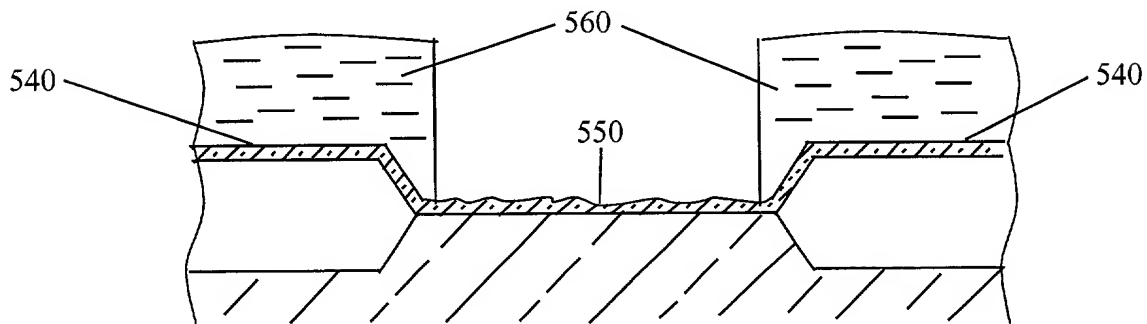


**FIGURE 4**

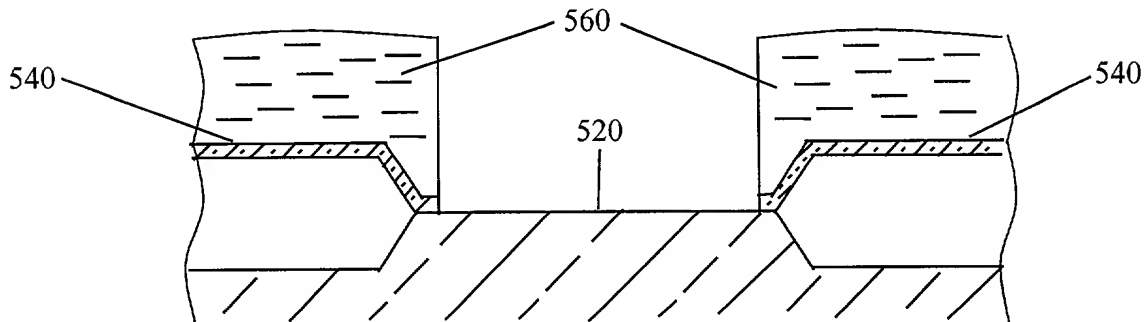
**FIGURE 5A**



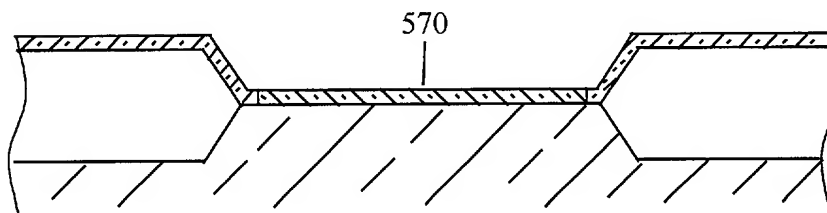
**FIGURE 5B**



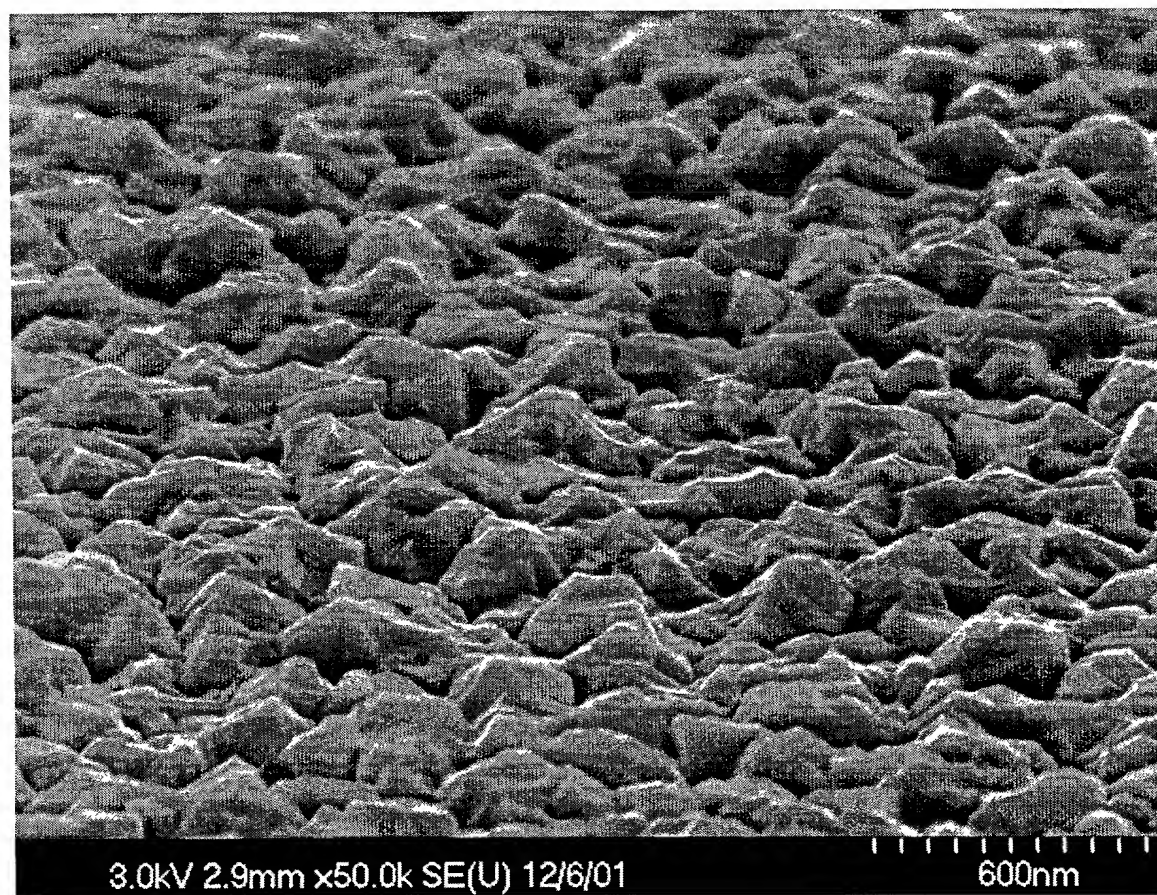
**FIGURE 5C**



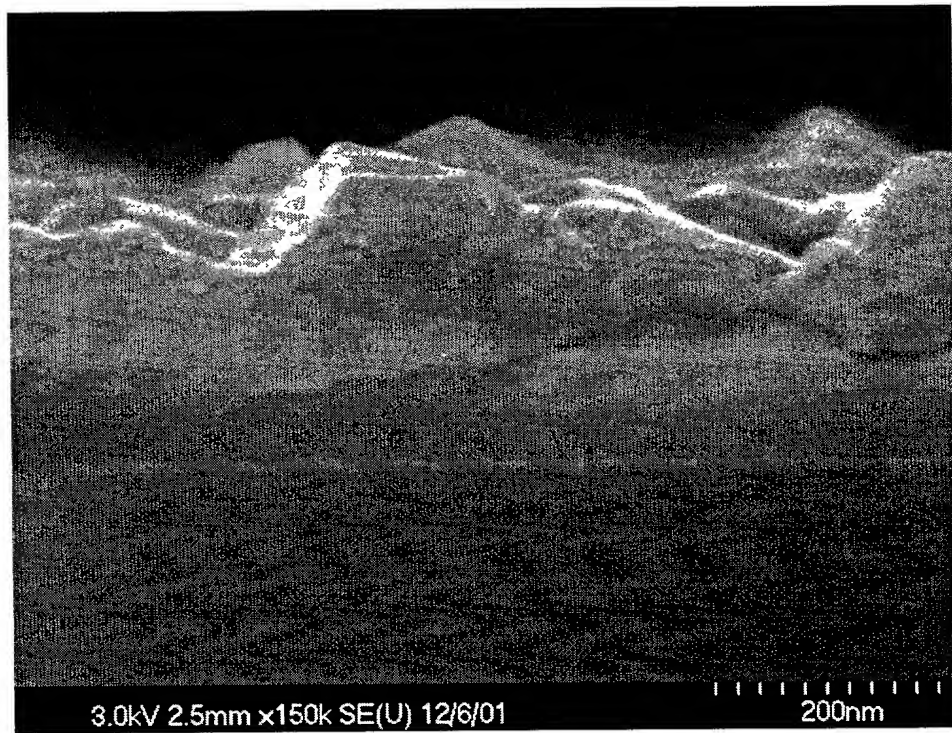
**FIGURE 5D**



**FIGURE 6**  
**SEM Photomicrograph of Si-Ge Film Deposited Using Silane and Germane**

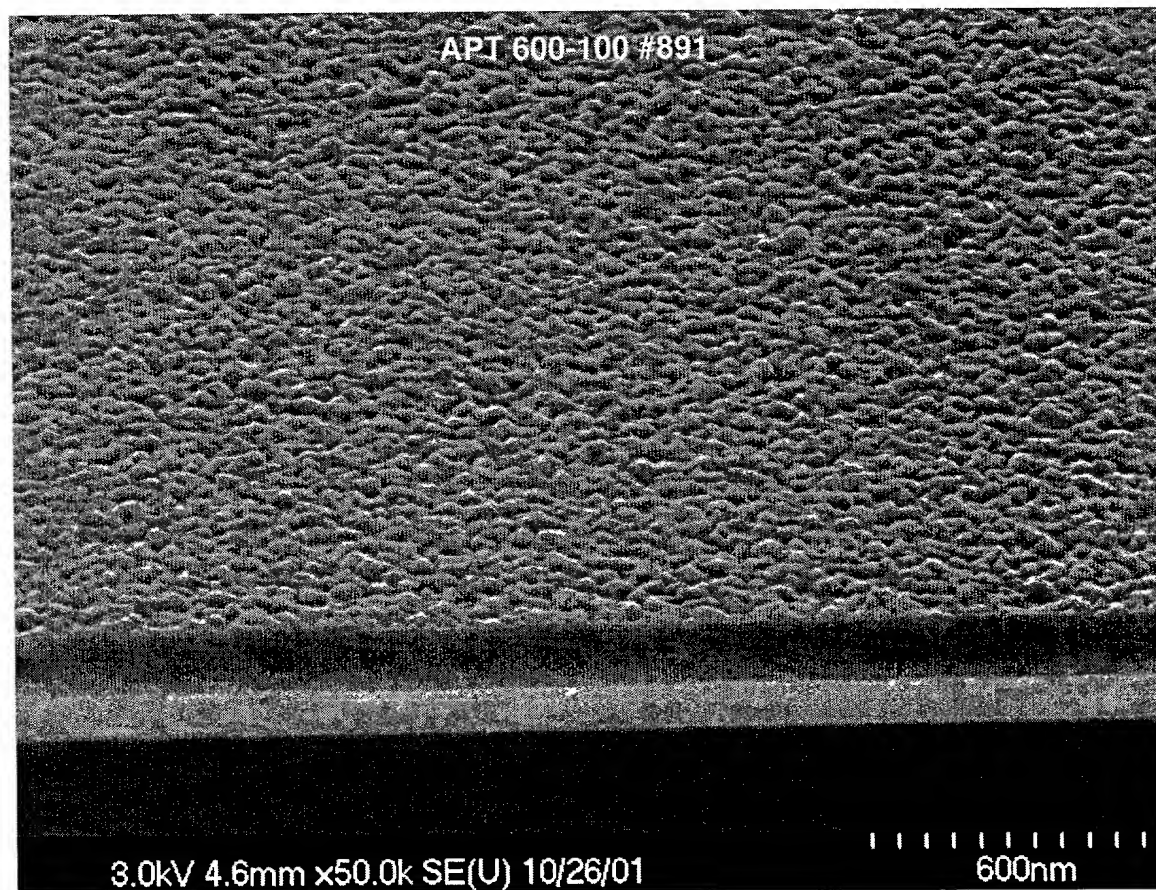


**FIGURE 7**  
**SEM Photomicrograph of Si-Ge Film Deposited Using Silane and Germane**



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**FIGURE 8**  
**SEM Photomicrograph of Si-Ge Film Deposited Using Trisilane and Germane**





**FIGURE 9**  
**SEM Photomicrograph of Si-Ge Film Deposited Using Trisilane and Germane**

